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Amendments to the Specification

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Please amend the paragraph at page 1, lines 7-9, in the following manner:

~~The present invention~~ This disclosure relates generally to a liquid container, a sub tank, a liquid discharge apparatus, a liquid supply apparatus, and an imaging apparatus.

Please amend the paragraphs at page 7, line 10 through page 8, line 19, in the following manner:

DISCLOSURE OF INVENTION SUMMARY

~~The present invention has been conceived in response to one or more problems of the related art, and one of its objects is to provide~~ In an aspect of this disclosure, a liquid container that can reduce the inflow of liquid into an air flow path ~~adapted configured~~ for discharging air from a liquid accommodating member, a liquid supply apparatus implementing including such a liquid container, and an imaging apparatus ~~implementing including~~ such [[as]] a liquid supply apparatus are provided.

~~It is~~ In another ~~object aspect of the present invention to provide this disclosure~~, a sub tank that is capable of generating a negative pressure using a simple structure, a liquid supply apparatus that ~~implements includes~~ such a sub tank, and an imaging apparatus that implements includes such a sub tank or liquid supply apparatus are included.

~~It is~~ In another ~~object of the present invention to provide aspect~~, an imaging apparatus is provided that is capable of supplying liquid to a sub tank according to a liquid consumption amount.

~~It is another object of the present invention~~ In another aspect, means is provided to enable negative pressure control of the sub tank when a nozzle restoration operation is being conducted so as to stabilize liquid discharge characteristics.

In ~~[[one]] another aspect of the present invention~~ this disclosure, a liquid container that accommodates liquid used in an imaging apparatus is provided, the liquid container including a liquid accommodating portion for accommodating the liquid and an air flow path for discharging air from the liquid accommodating portion,

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the air flow path including an entrance flow path portion that is connected to the liquid accommodating portion, and a continued flow path portion that continues from the entrance flow path portion, the continued flow path portion being arranged to extend in an upper diagonal direction with respect to a reference plane corresponding to a liquid level of the liquid accommodated in the liquid accommodating portion at a standstill state. Herein, the liquid may be prevented from penetrating into the atmospheric release side of the air flow path when fluctuation of the liquid level occurs.